

# VFCAL Report

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Infrastructure for sensor diagnostics

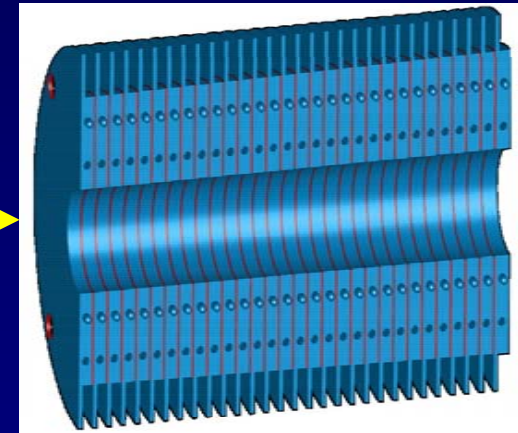
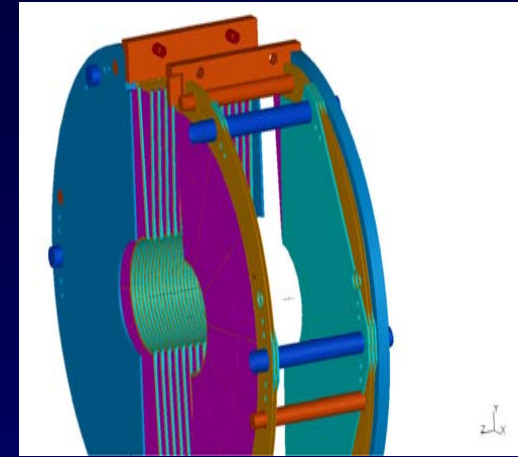
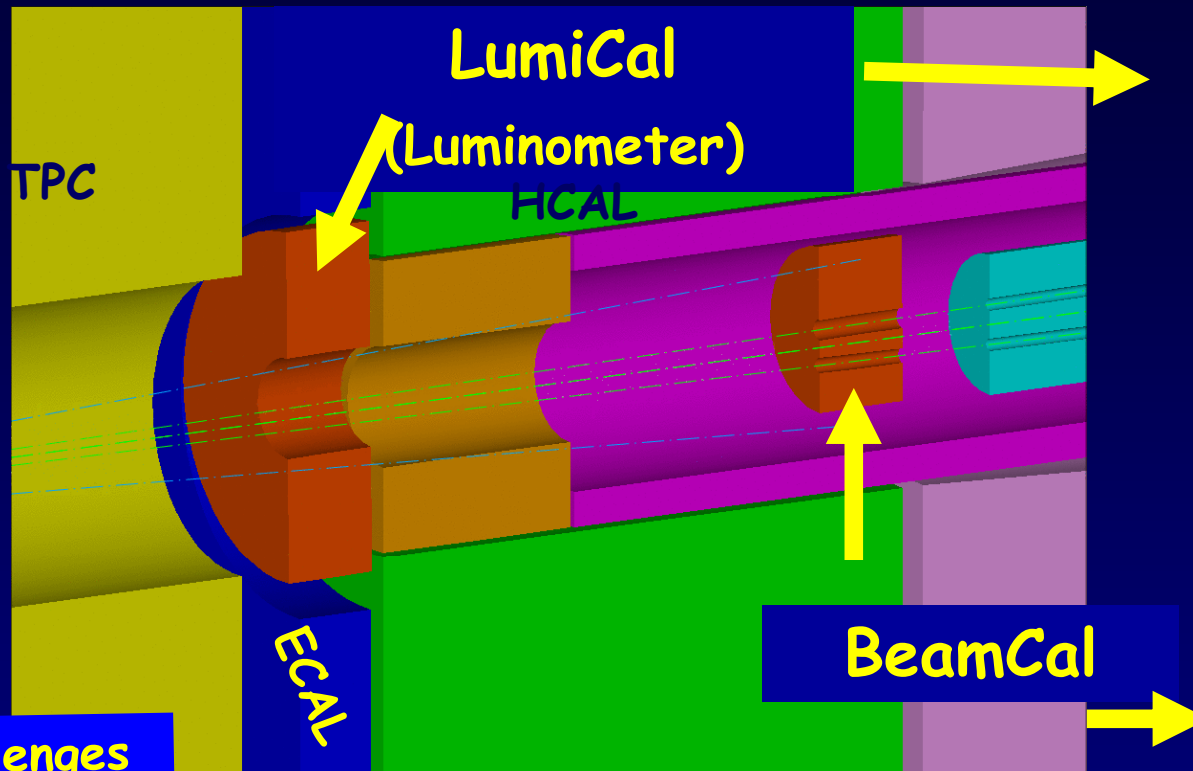
FE Electronics Development

Sensor test facilities and testbeam

Laser Alignment

Labs involved: Cracow UST, Cracow INP,  
Prague (AS), Tel Aviv Univ.  
DESY (Z.)

## Current design (Example LDC, 14 mrad):



### Challenges

LumiCal: -control of position on  $\sim 100 \mu\text{m}$  level  
-control of the inner acceptance radius on  $\sim \mu\text{m}$  level

BeamCal: -radiation hard sensors ( $\sim 10 \text{ MGy/year}$ )

Both: -compact (smallest possible Moliere radius)  
-readout after each BX

## Infrastructure for Sensor and FE Tests

### Clean Rooms (Cracow, DESY, Tel Aviv)

#### e.g. DESY

two rooms with filtered air (10k), stabilized temperature

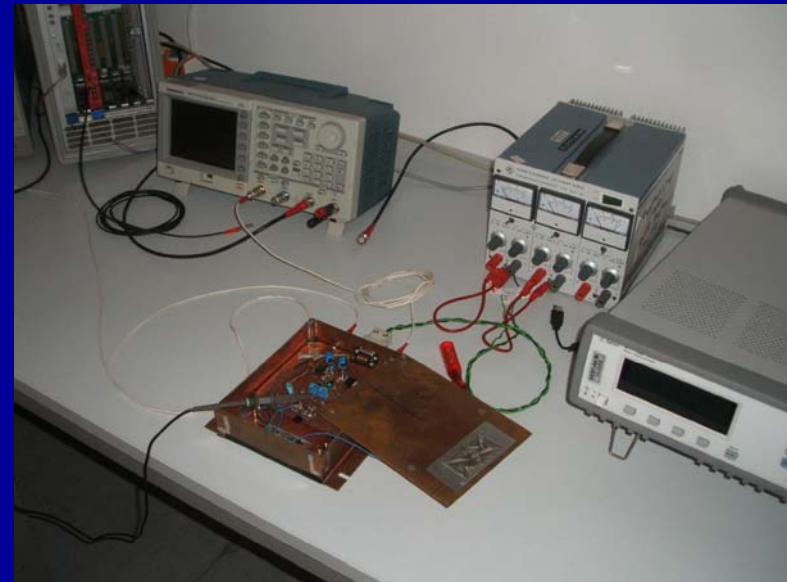
- room 1: bonding and assembly
- room 2: all measurements without radioactive source

### Upgrade of the probe station at DESY

- New voltage- current devices (Keithley 6487)
- Control software
- Amplifier test bench



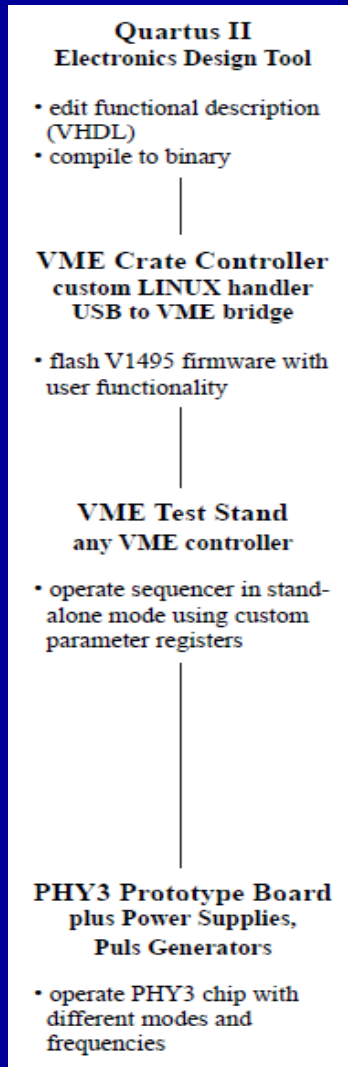
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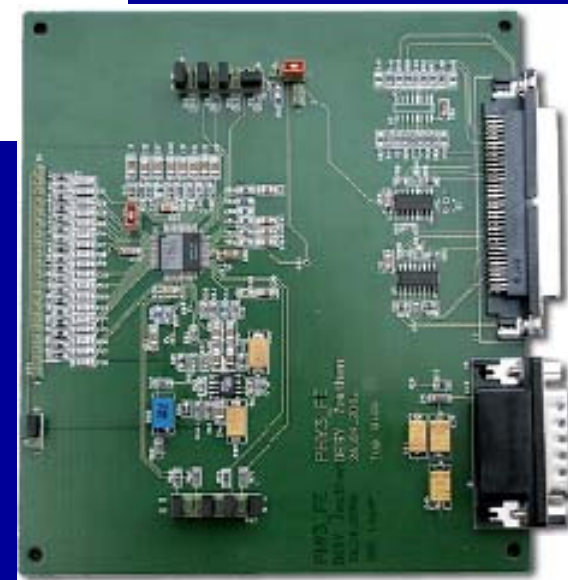
# Infrastructure for Sensor and FE Tests

## Design Flow for IC readout chip tests with the custom sequencer V1495



**C.A.E.N. V1495**  
general purpose  
I/O module

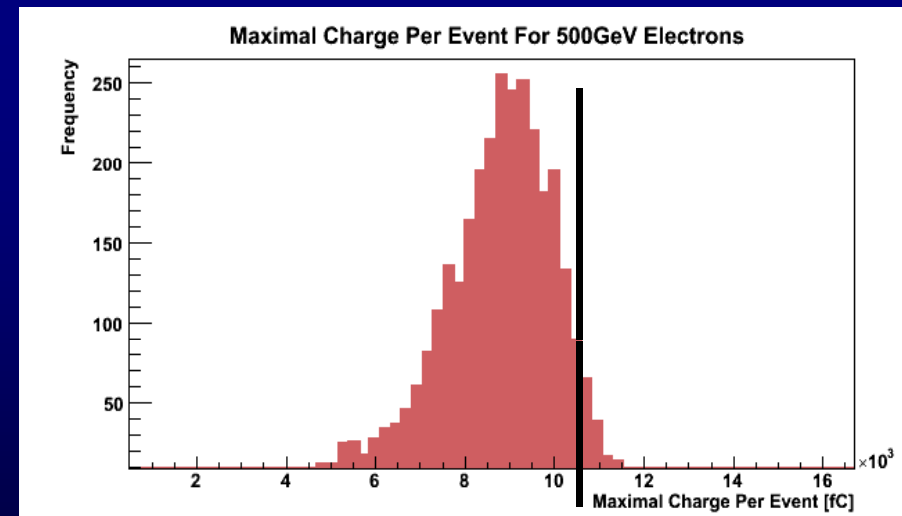
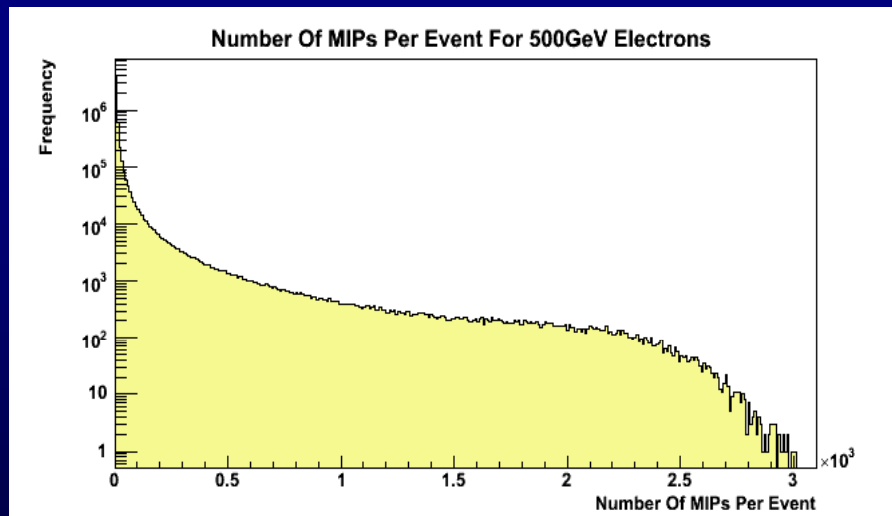
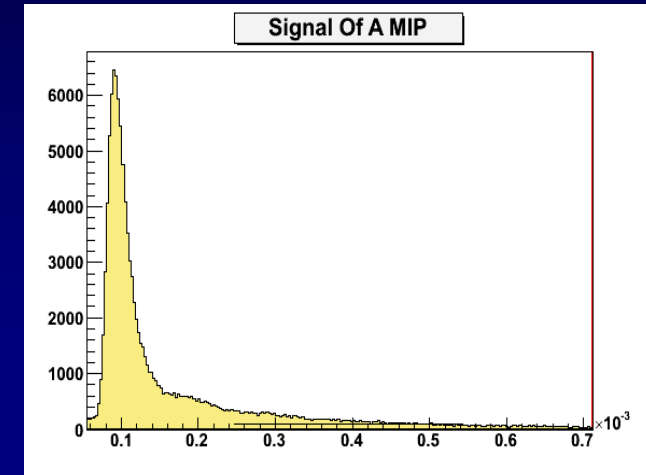
w/ LVDS and NIM  
In/Out channels



Test Example: PHY3

# Simulation Studies for the FE design

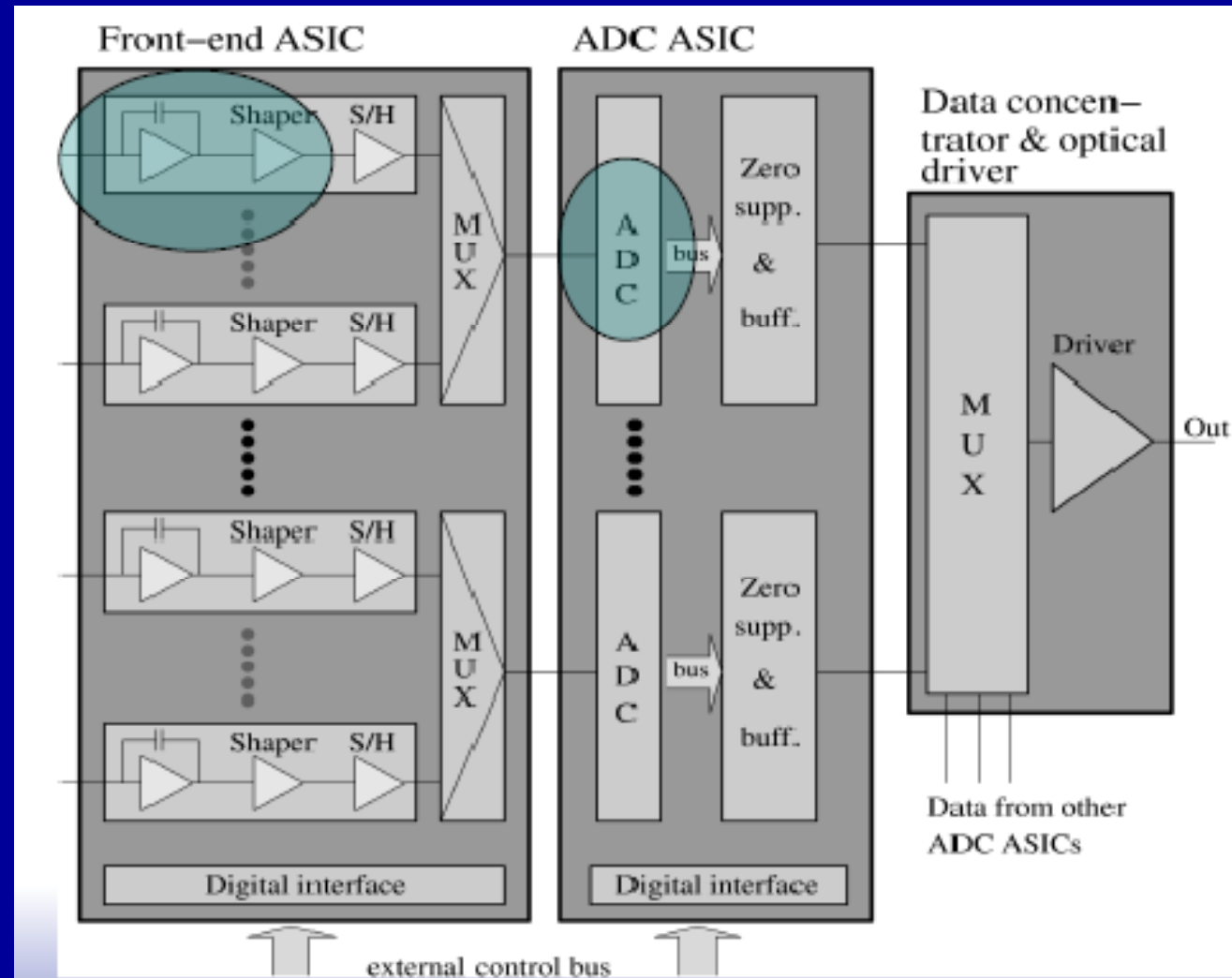
1. 500 GeV electrons for 8-Bit & 10-Bit schemes.
2. Energy MPV of a MIP in 0.3 mm thick silicon is 93.8 KeV.
3. The maximal number of MIPs in a single cell is 3,010.
4. 95% of the signal is below 10,575 pC = 2,586 MIPs.



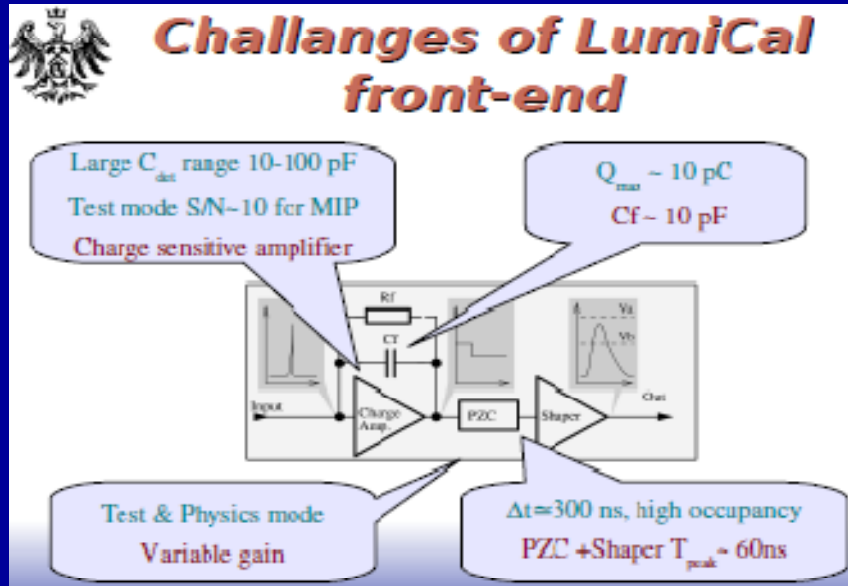
# FE Electronics Development

One FE ASIC will contain 32 - 64 channels

One ADC will serve several channels  
(MC simulations Still not finished)

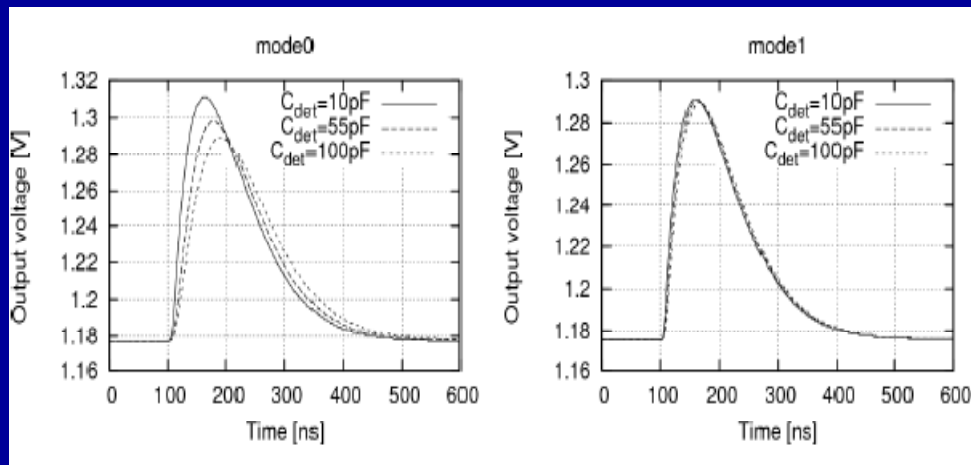


# FE Electronics Development

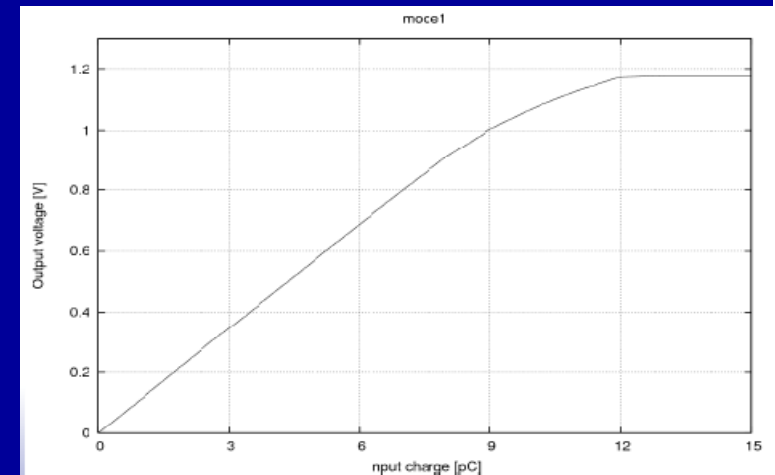


Estimates of signal range and occupancy from MC simulations, translated into design requirements

Response in test- and physics mode for different  $C_{det}$

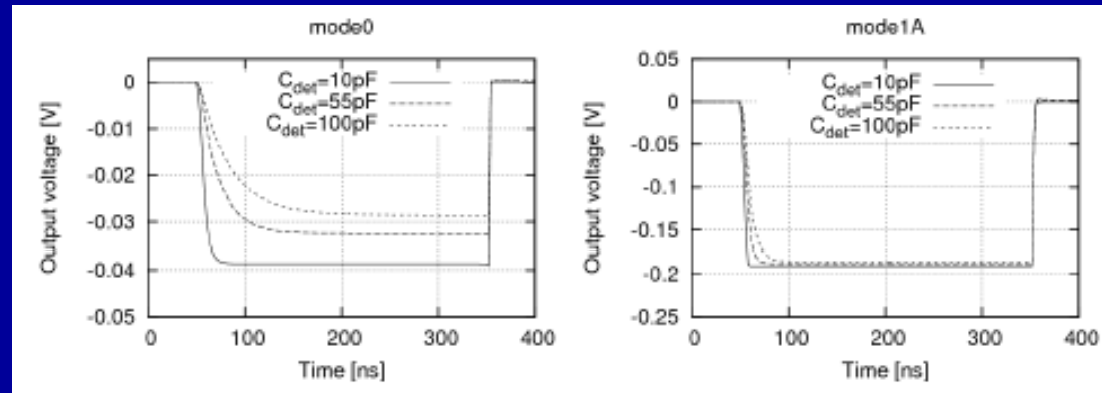
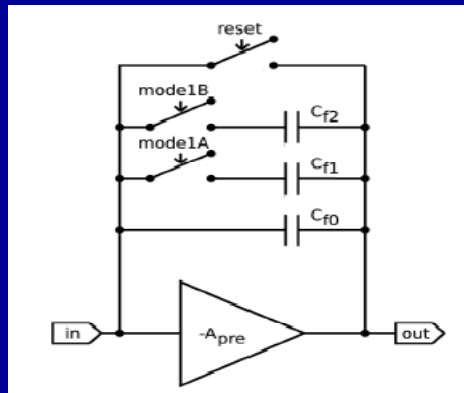


Linearity over the signal size range<sub>+</sub>



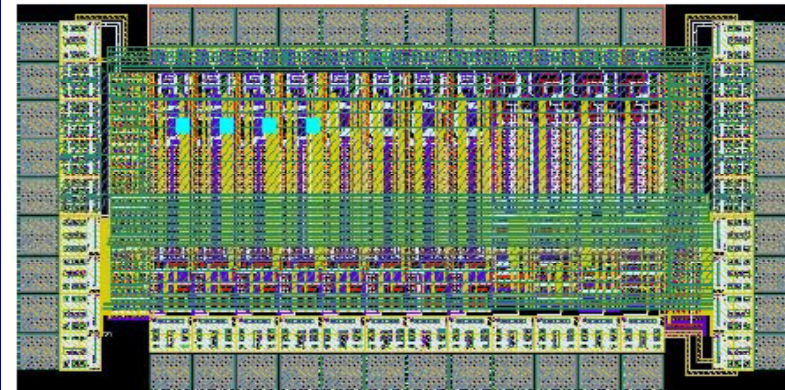
# FE Electronics Development

## Alternative: Switched reset configuration



Prototype ASIC with 12 channels  
Submitted in June 2007

4 channels preamp+PZC+CR-RC  
4 channels preamp+PZC+CfRf  
4 channels switched reset



Pad Pitch 100  $\mu\text{m}$



## FE Electronics Development

End of Septembre 2007:

- 40 ASICS received
- test PCB designed and produced
- test bench setup under construction
- first results using a generator and an external capacitance

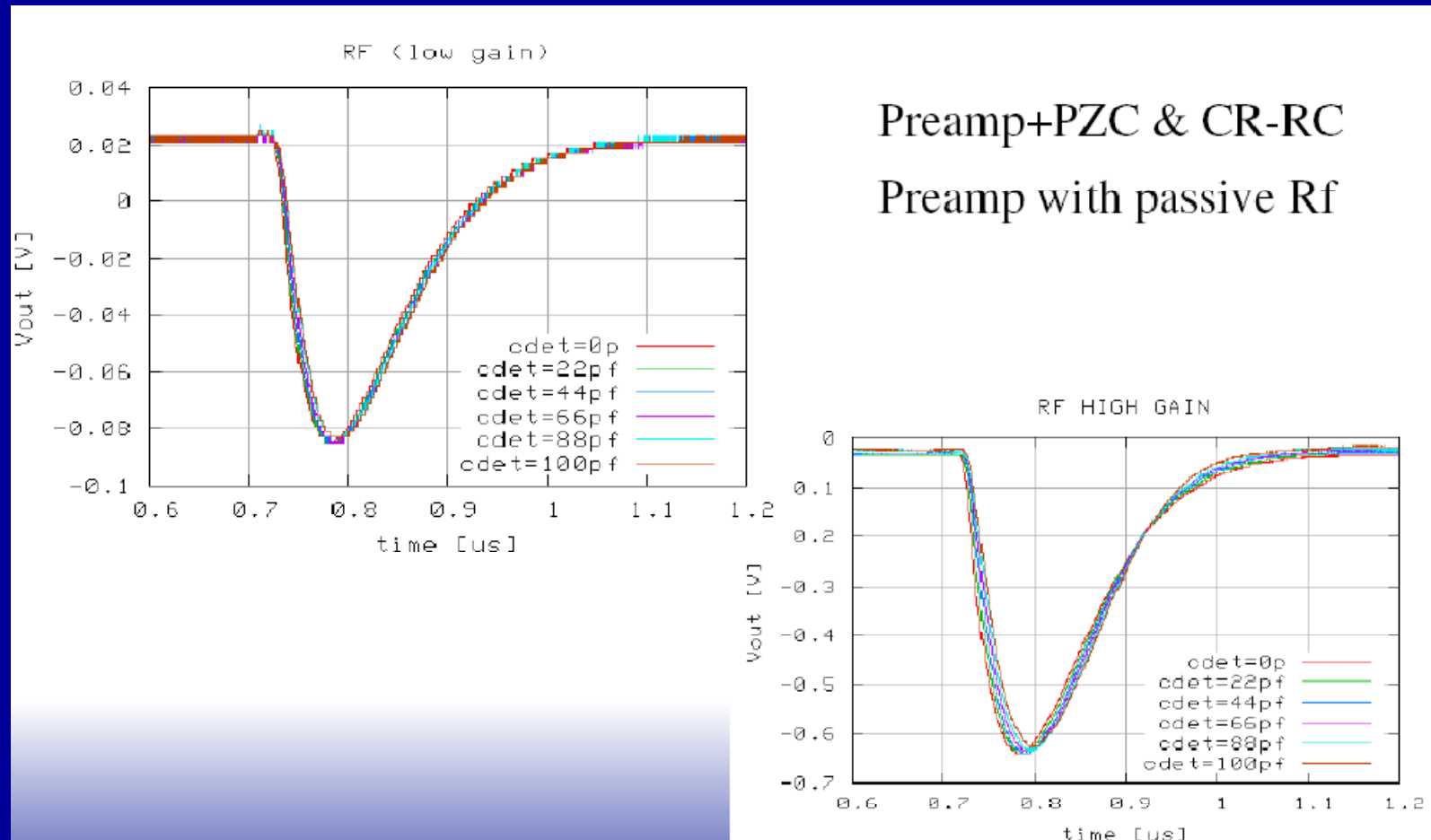


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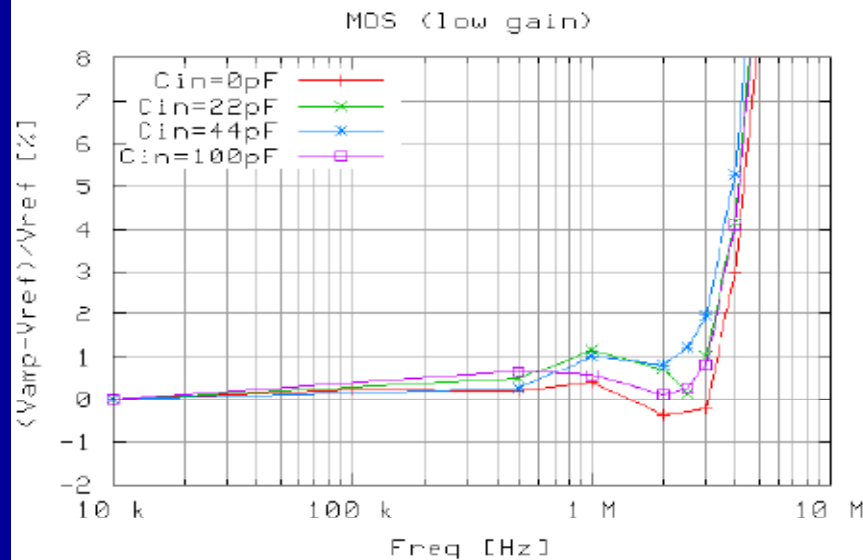
# FE Electronics Development

First Results: Output signal shape for different input capacitances



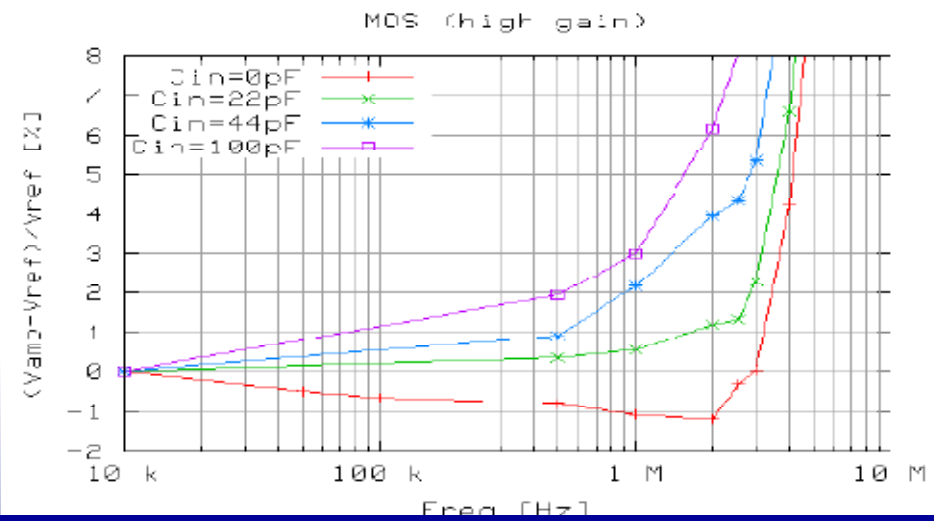
# FE Electronics Development

## First Results: Output signal vs. input signal frequency



Preamp+PZC & CR-RC

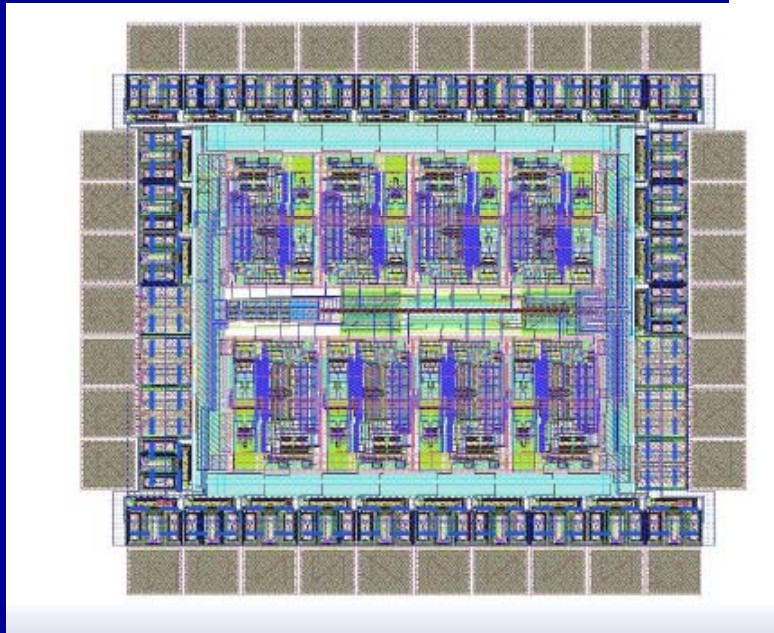
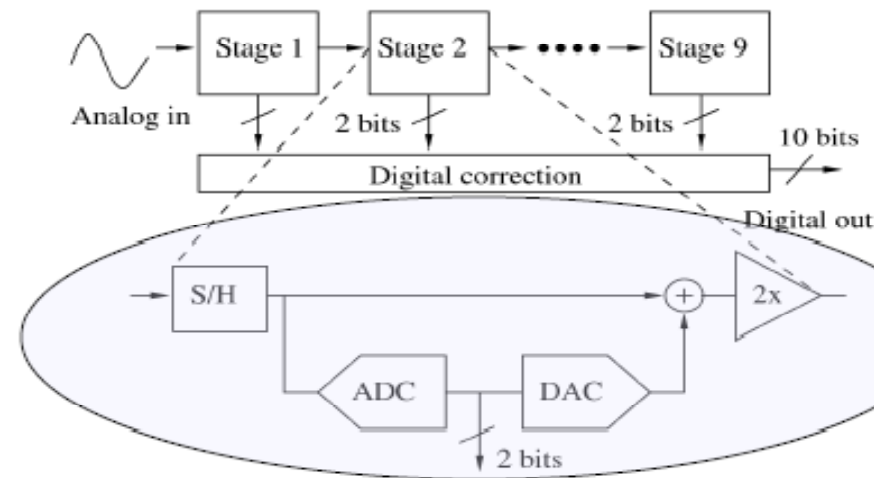
Preamp with active MOS  $R_f$



# FE Electronics Development

## Pipeline ADC concept:

- High throughput
- High robustness
- Power efficient
- Reasonable area



-Prototype ASIC containing 8 pipeline stages submitted in June 2007

- First pieces are alive

- Test Results in December 2007

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## FE Electronics Development

- Design description will be ready in December (EUDET Note)
- Performance results supporting the design
- Improved design beginning 2008

Everything is well on schedule

# Test Beam Equipment and sensor tests

Setup used for radiation hardness tests at the SDALINAC accelerator

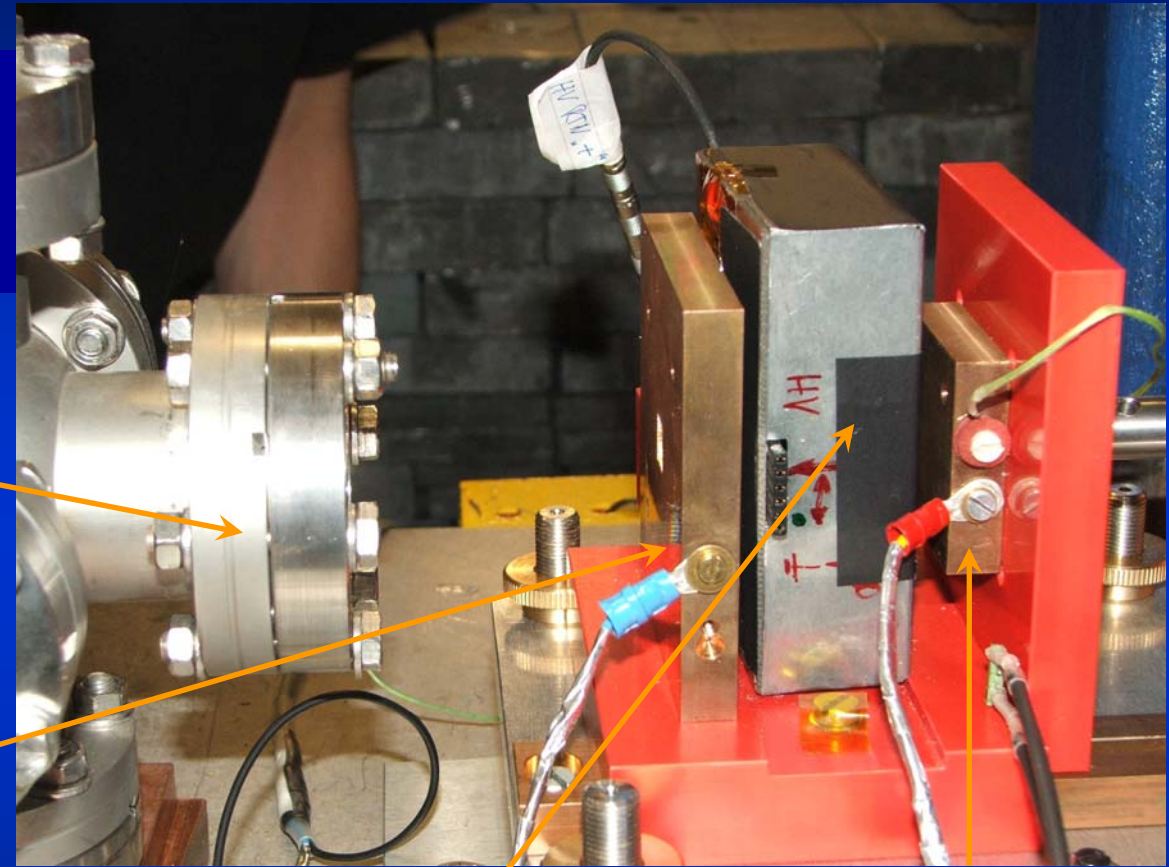
TU Darmstadt

exit window of beam line

collimator ( $I_{Coll}$ )

sensor box ( $I_{Dia}$ ,  $T_{Dia}$ , HV)

Faraday cup ( $I_{FC}$ ,  $T_{FC}$ )



Completed and more comfortable: more efficient use of the beam

# Testbeam

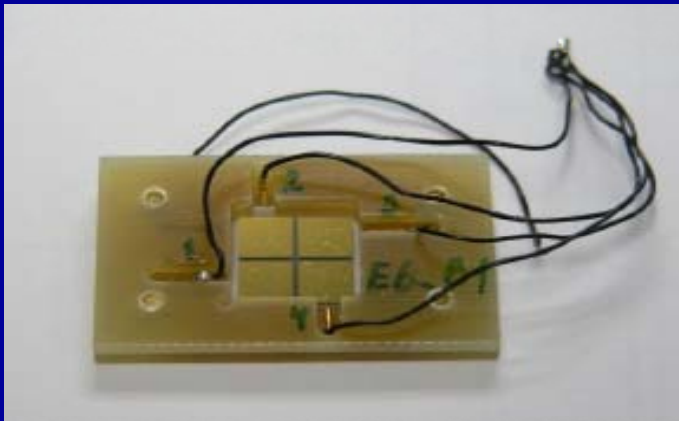


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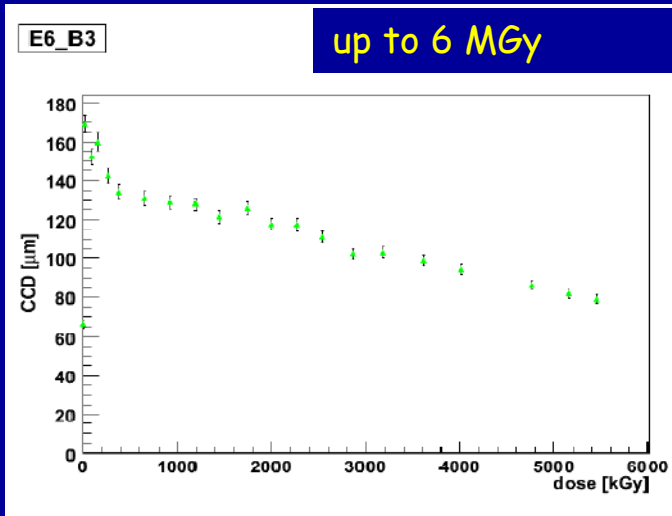
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# Test Beam 2007

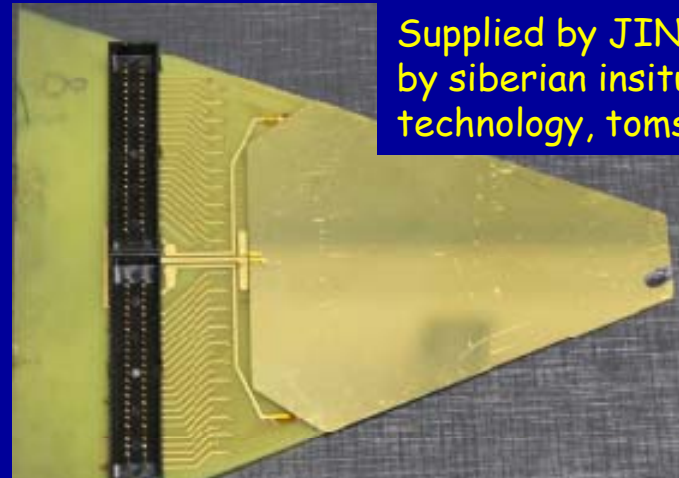
- Completion of Diamond sensor tests
- Test of GaAs sensors
- Test of rad. Hard Si sensors, delivered by BNL and Prague



diamond sensor prototype

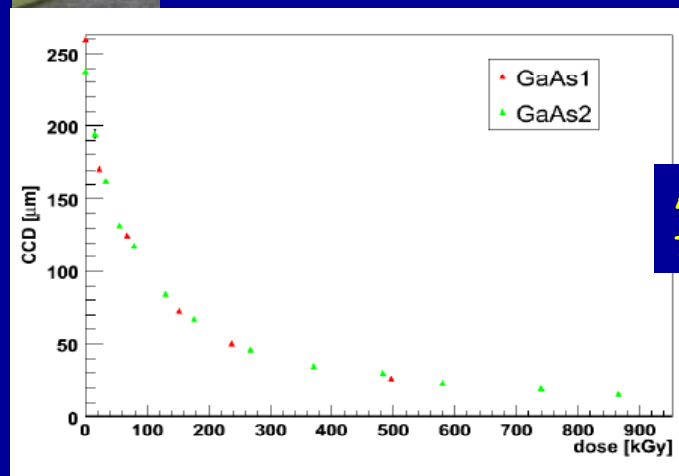


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Supplied by JINR, produced by siberian insitute of technology, tomsk

GaAs sensor prototype



About factor 10

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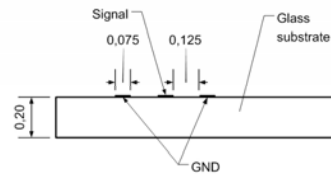


# Silicon Sensors for LumiCal

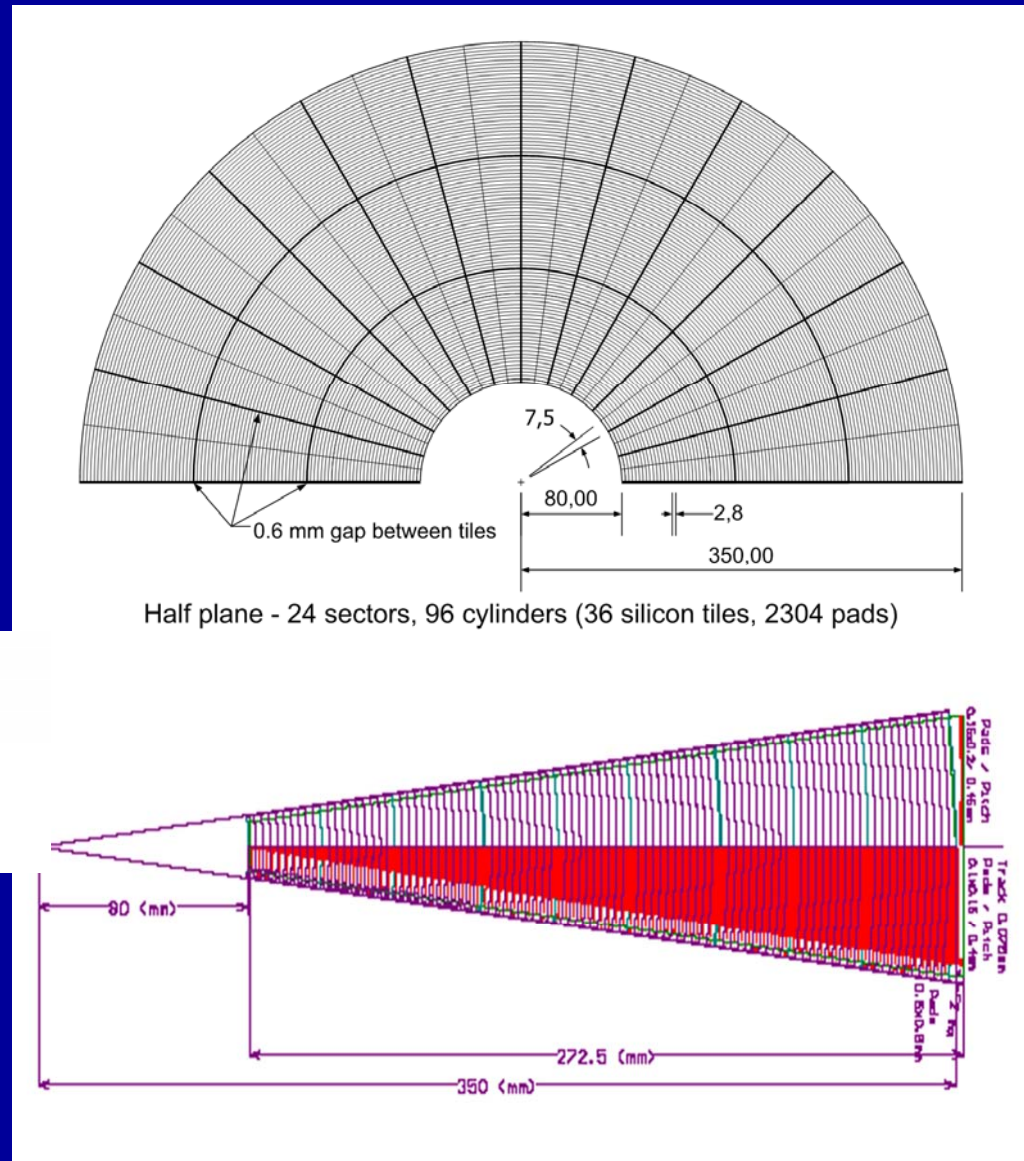
- Sensor prototypes designed
- Contacts to several manufacturers

Tower Semiconductors Israel  
Hamamatsu  
Canberra  
Sintef

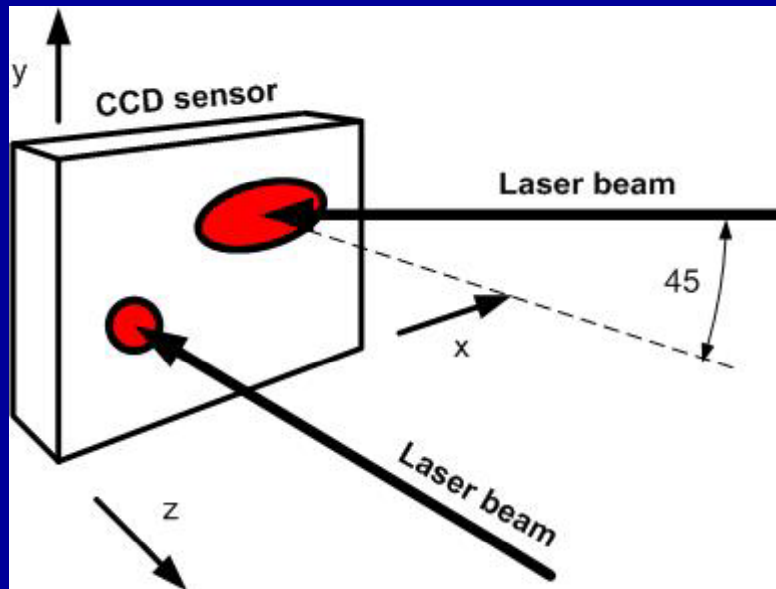
- Fan-out design



- Sensor Prototypes for tests expected in 2008

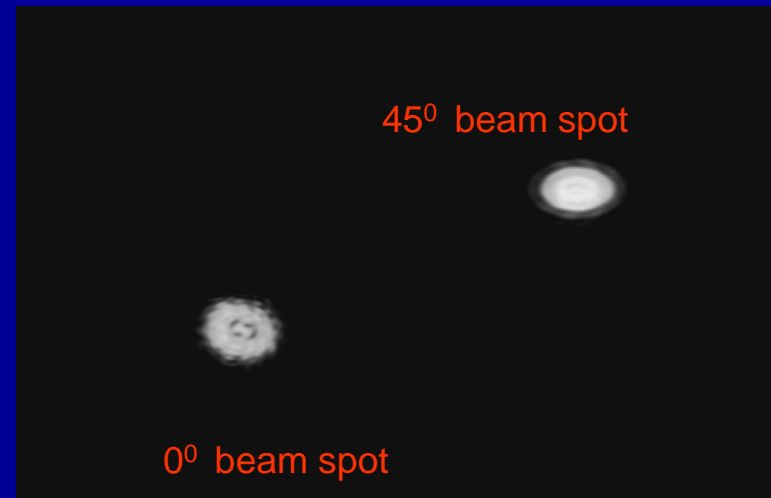
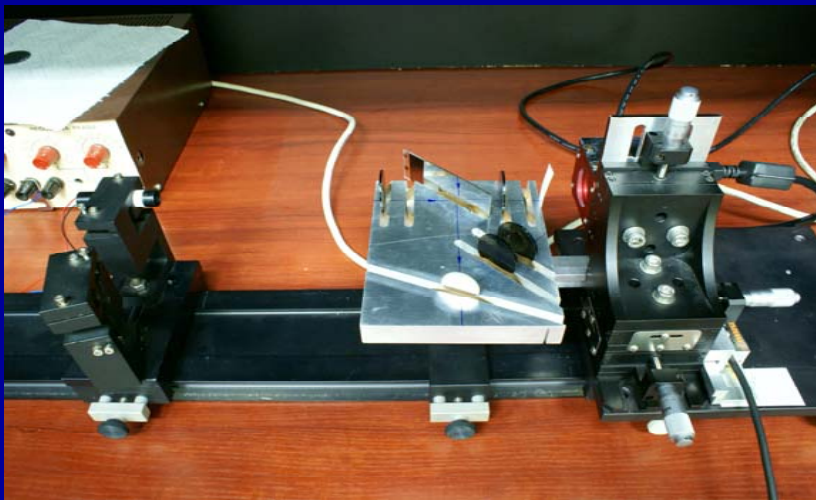


# Laser alignment system



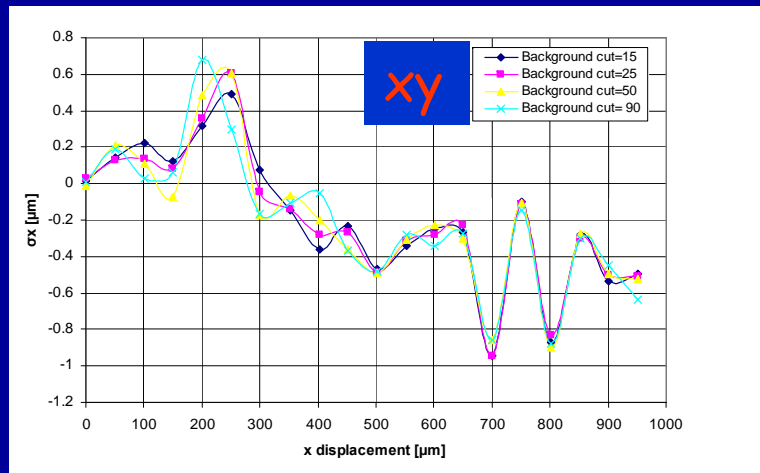
Two laser beams (one perpendicular, second with 45° angle to the sensor plane) allows to measure XYZ translation in one sensor

Laser beam spots  
on the surface of  
CCD camera  
(640 x 480 pixels)

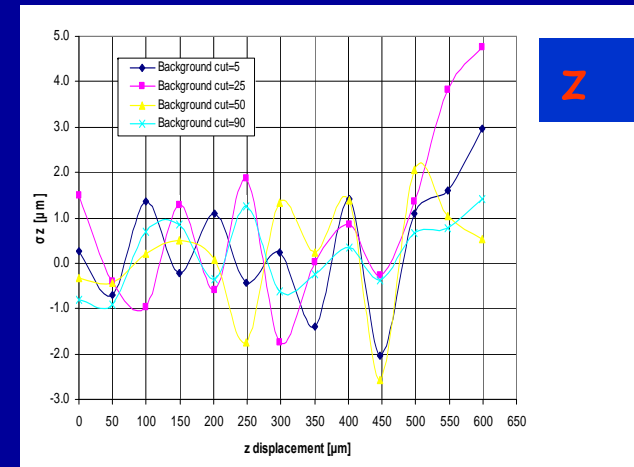


# Results and Status

±  
0.5 μm



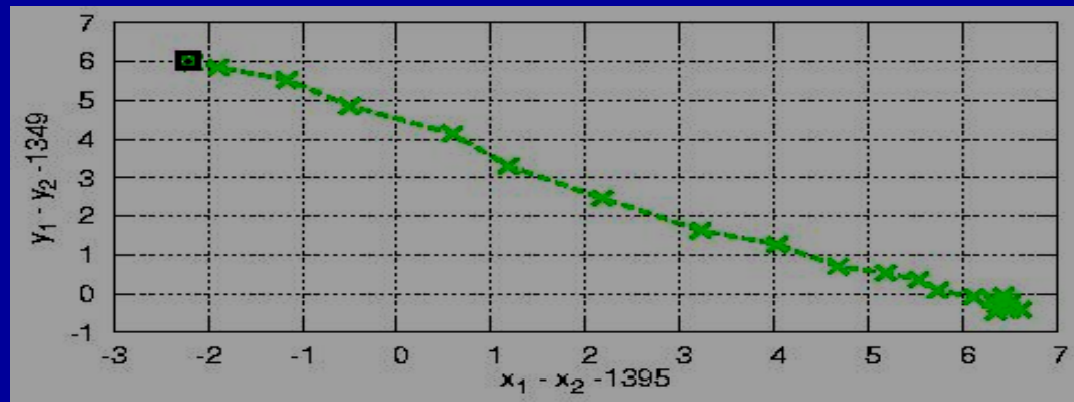
±  
2 μm



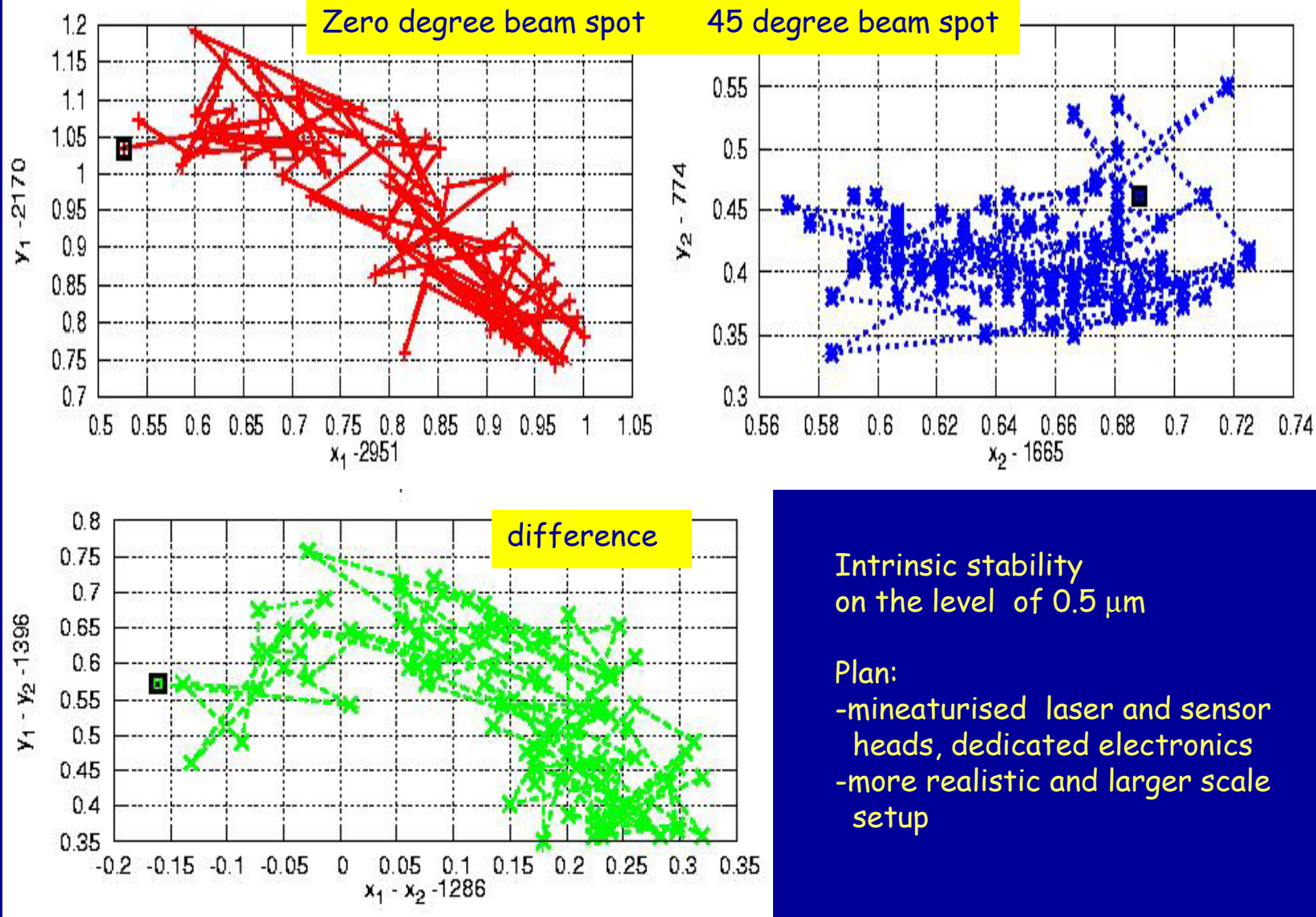
Camera has been moved in steps of 50 μm. The distance have been measured with Renishaw RG-24 optical head with the resolution of ±0.1 μm

Study of the temperature dependence:

The observed changes are on the level ~ 1 μm/1 °C



# Long-term measurements (~day)



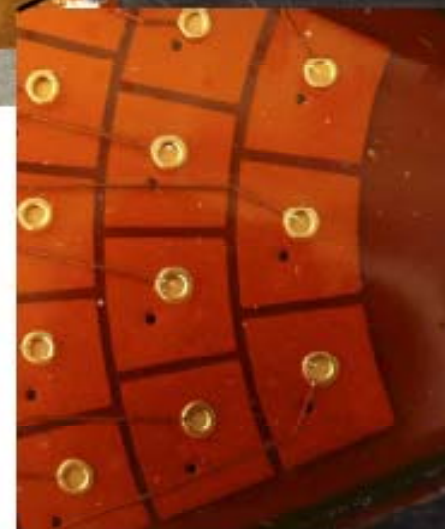
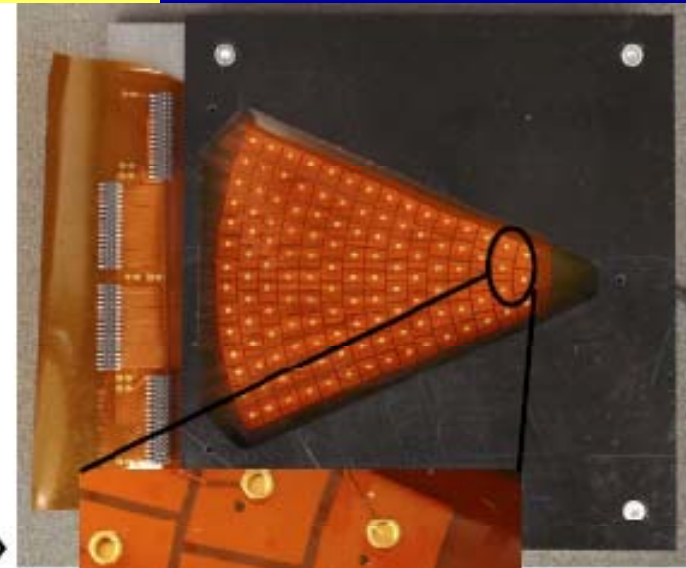
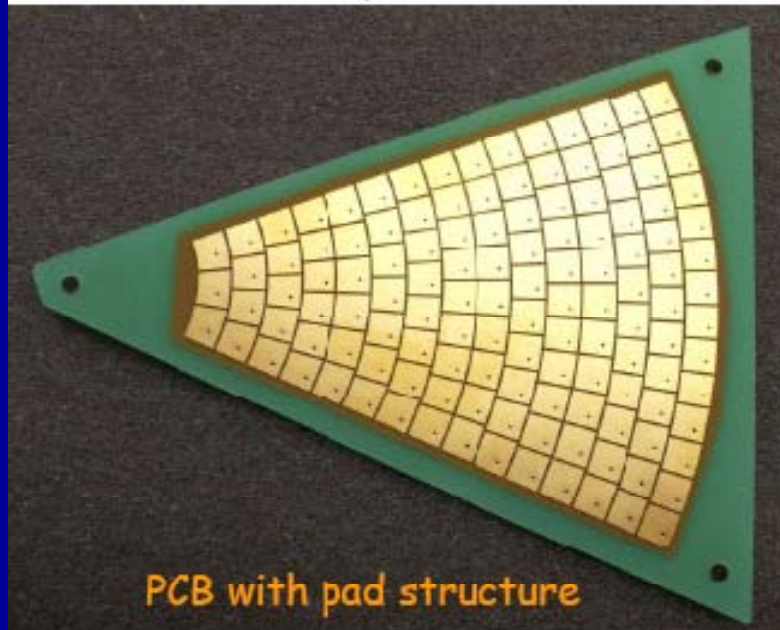
Intrinsic stability  
on the level of 0.5  $\mu\text{m}$

- Plan:
- minaturised laser and sensor heads, dedicated electronics
  - more realistic and larger scale setup

## Fan-out for a sensor plane



+



Readout structure prototype with metal pads bonded to capton readout

## Plans and Summary

- Laboratory infrastructure is created/improved/completed
- Testbenches for FE ASICs prepared
- First FE ASICs are produced, tests started
- Testbeam equipment for rad. hard tests completed and used
- Laser positioning system studies are ongoing
- First steps towards a fully instrumented 'ultrathin' sensor plane

VFCAL is 'on schedule'